

ELECTRONICS AND SOFTWARE BASED SYSTEMS AUSTRIA

6 March 2024, Chips JU 2024 Information Day,

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Activities ESBS-Austria 2024 (planned)

Events

- 13 May Austrian IPCEI Day, organized in cooperation w/Infineon, Vienna
- 14 May ESBS-Austria spring conference "Chips JU" and General Assembly, Vienna
- 7 Nov Fall event ESBS-Austria, Linz

Network/Strategy

- European Competence Centers: process ongoing, no detailed information yet; cooperation w/Italy welcome (8 Mio/4yrs; deadline call: Apr 11, 2024)
- Pilot Lines: Cooperation & coordination in Austria by Silicon Austria Labs (SAL)
- Austrian Chips Forum: close cooperation with public authorities on national level (BMK federal ministery of climate action)

(External) visibility

- 25 Jun IMAGINE24 ,Re-inventing digital technologies', Vienna, target group researchers and students
- 2024 Call & awarding of 3 ebs-related Bachelor/Master Thesis with esbs focus



Silicon Austria Labs (SAL) short overview

PILOT LINEs: contribution in Pilotline 2 & 4

AT- C3 COMPETENCE CENTER AUSTRIA

SILICON AUSTRIA LABS (SAL)

What drives us?

As a **industrial research center** and **pioneer in EBS**, we offer the industry, access to top-class R&D infrastructures & research services to give them the decisive competitive advantage on both domestic and on international soil.

We provide EBS Key Enabling Technologies for Smart, Connected, Dependable, Sustainable and Miniaturized Solutions

We offer cost-effective research through More-than-Moore, Photonics, 6G, High Power Density Converter and Dependable EBS







EXPERTS

- Experienced team
- 40 nations
- Multidisciplinary



20



- 50,1 % Republic of Austria (BMK)
- 24,95 % FEEI
- 10 % Styria (SFG)

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- 10 % State of Carinthia
 - 4,95 % Upper Austria (UAR)

RESEARCH UNITS in 5 DIVISIONS:

- Sensor Systems
- Microsystems
- Power Electronics
- Embedded Systems
- Intelligent Wireless Systems



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Confidential



SAL MICROFAB



Lithography



SAL





SAL operates two Cleanrooms at its Villach site (SAL MicroFab):

•A 400 m² ISO5/6 cleanroom for single wafer processing up to 200mm – established 2016 with total investment > 10 mio€.

•A 1100 m² ISO4/5 cleanroom for semi-automated 200mm wafer processing and small series production – established 2023 with total investment 18 mio€.

Further, SAL operates additional ~1000 m² facilities for the characterization of RF, piezoelectric, acoustic, photonic, and magnetic properties of MEMS devices.

Focus of SAL's activities within its cleanroom facilities is the development of ultra-high performance thin-film technology and related microfabrication for sensor, actuator, photonic, RF MEMS, and power electronic devices throughout the entire industrial value chain. SAL functions as an applied research centre, offering access to a cutting-edge cleanroom infrastructure for advanced thin-film technology, facilitating industrial deployment and related microfabrication processes for "More than Moore" applications. The research and technology staff at SAL has more than 25 years' experience in developing electronic based systems and works according to ISO 9001:2015 certification.





EMBEDDED SYSTEMS

POWER

ELECTRONICS



INTELLIGENT WIRELESS SYSTEMS



MICRO-SYSTEMS





Chips 2023-CPL-2 Advanced Fully Depleted Silicon On Insulator technologies targeting 7nm . MAX. EU 420 (M€) FAMES – FD-SOI PL FOR APPLICATIONS WITH EMBEDDED NON-VOLATILE MEMORIES, RF, 3D INTEGRATION AND PMIC, TO ENSURE EUROPEAN SOVEREIGNTY

Coordinator: CEA-Leti

11 Partners, from FR, DE, BE, FI, IE, AT, SP

4 Hosting Sites: CEA-Leti, Tyndall, VTT and SAL

FAMES Pilot Line will develop advanced technologies offering 2 generations of FD-SOI at 10nm and 7nm.

Among others SAL SAL will take on the difficult task of integrating magnetic layers into FD-SOI technology. Activities include the design and microfabrication of RF MEMS including all process steps from thin film process developments, patterning, passivation, as well as 3D integration of the RF devices onto 300 mm FD-SOI reconstructed wafers.

Chips 2023-CPL-4 Advanced semiconductor devices based on Wide Bandgap materials – MAX: EU 180 (M€)

WBGPILOTLINE

Coordinator: Consiglio Nazionale delle Ricerche (CNR)

14 Partners, from IT, SE, PL, FI, AT, FR, DE

WBG Pilot Line aims to realise an integrated PL focused on the developments of the wide-bandgap (WBG) semiconductors technologies for power and radio frequency (RF) electronics.

SAL MicroFab will provide a unique technological portfolio to the European ecosystem by focusing on development and integration of (ultra-)wide band gap thin films, and the related metallization/passivation/microfabrication steps necessary to fabricate RF power components.



Pilot Line 02

FD-SOI technology at 10nm and beyond



- \equiv More-than-Moore markets
 - RF connectivity, automotive, loT
- Including 3D-SOC integration

Federal Ministry Republic of Austria Climate Action, Environment, Energy, Mobility, Innovation and Technology



Advanced thin film technologies for RF passive devices

- Magnetic thin film development on 200mm/300mm wafers
- Advanced Cu electroplating technology on 200mm/300mm wafers
- Seed layer engineering (HiPIMS), comformal passivation (ALD)
- Micropatterning for RF passive devices

Transversal thin film technology for WBG devices

- Nitride epitaxial thin film deposition on wafers for power devices and RF MEMS
- UWBG AI(X)N material development for high-mobility semiconductor applications
- \equiv Interface engineering for power devices and RF MEMS
- Advanced microfabrication technologies for power devices and RF MEMS
- Back-end thin film deposition for power devices and RF
 MEMS
 MEMS

Pilot Line 04 Wide Band Gap materials

- SiC and AlGaN/GaN technologies
- Power electronic and RF applications



Some of the Possible Supporters (t.b.d.via Letter of Support)

ESBS

AUSTRIA

AT-C3: COMPETENCE CENTER AUSTRIA

NATIONAL CALL is Open Deadline 11 April 2024







Software-defined vehicle (SDV) platform and Noninitiative calls 2024



Transform the mobility industry for a safer and more sustainable future: THE AUTONOMOUS

Author: Francesca Flamigni (TTTech Computertechnik AG)





The Autonomous

The initiative – The Autonomous event on 23-24 Sept 2024 in Vienna (Austria)





Initiated in 2019 by TTTech Auto. The Autonomous is a community platform shaping the future of : The Autonomous Main Event

AUTONOMOUS THE



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Our Mission is to facili autonomous mobility

flagship event of the initiative

September

The annual



23-24, 2024 At The Autonomous N experts of the industry autonomous vehicles



historic building 500+ Executives, **Decision-Makers** and Innovators



Incredible staging and show

THE **AUTONOMOUS**

Onsite meeting spaces

Live stream and virtual platform



Day 1 Workshops

Expert Circle Working Group Networking Sessions



Day 2

Panel Discussions

Keynotes

Networking sessions





Spotlight Session on Autonomous mobility and the role of international collaboration @TheAutonomous

Tlech

(previous edition - 2023)

- Focus on cooperation for sustainable solutions in autonomous mobility
- Taking stocks from the results of ongoing R&D projects (i.e. A-IQ Ready and EcoMobility) and programmes (i.e. CCAM – SUNRISE project)
- Insights on global market trends in autonomous mobility by European Commission
- Funding opportunities in ongoing and future programmes such Chips-JU, CCAM, 2ZERO.





For more information visit: www.the-autonomous.com

Previous edition: <u>https://www.tttech.com/road-</u> autonomous-mobility-europe-places-focus-collaboration



ESBS-Austria

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THANK YOU!

Federal Ministry Republic of Austria Climate Action, Environment, Energy, Mobility, Innovation and Technology